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BUCHANAN INGERSOLL PC One Oxford Center, 20th Floor

Pittsburgh, PA 15219

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

PATENT APPLICATION

Jayashankar et al.

SINGLE LAYER RESIST LIFT-OFF PROCESS AND

APPARATUS FOR SUBMICRON

Ref. No. 011333

STRUCTURES

Serial No: 10/087,510

Group Art Unit: 1765

Filed: March 1, 2002

TRANSMITTAL LETTER

Pittsburgh, Pennsylvania 15219 September 11, 2002

Assistant Commissioner for Patents Washington, D.C. 20231

Dear Sir:

Enclosed please find an Application Data Sheet (2 pages) for the above-identified application. The Application Data Sheet includes the bibliographic data as set forth in 37 C.F.R. § 1.76.

> RECEIVED SEP 1 6 2002 1C 1700

As set forth in the Application Data Sheet, the above-identified application has been assigned to Seagate Technology LLC. Applicants respectfully request that the Assignee Information appear on the published application.

Respectfully submitted:

66hn E. Grosselin, III, Esquire

Registration No. 38,478

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